

PATENT Attorney Docket No. 211843-00032

IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.:

10/519,699

I.A. Filing Date:

June 26, 2003

Inventor(s):

Horsky, et al.

Title:

Ion Implantation Device and a Method of Semiconductor Manufacturing

by the Implantation of Boron Hydride Cluster Ions

Group Art Unit No.:

2881

Confirmation No.:

6928

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Please correct the attached, marked-up copy of page 1 of the official filing receipt as follows:

Under "FIL FEE REC'D": delete "1440" and insert -- 2880-- therefor (see the attached "Correction of Entity Status and Payment of Fee Deficiency" filed by facsimile on September 14, 2005, which confirms the correct filing fee amount of \$2880);

The customer number (and its corresponding address) should be changed from "27180" to --27160-- (see the attached copy of the Declaration filed on September 14, 2005, which provides a customer number of 27160);

Under "Applicant(s)": delete "Bozborough" and insert -- Boxborough-- therefor, and delete "Dale Jacobson" and insert -- Dale C. Jacobson—therefor (see the attached copy of the Declaration filed on September 14, 2005, which sets forth the correct applicant data); and

Application No. 10/519,699 Attorney Docket No. 211843-00032 Page 2

Under "Domestic Priority data as claimed by applicant": after "04/18/2003" insert -- and is a CIP of 10/183,768 06/26/2002-- (see the attached Preliminary Amendment filed by facsimile on January 20, 2006, which amends the priority claim in the specification).

Respectfully submitted,

KATTEN MUCHIN ROSENMAN LLP

Bv:

John S. Paniaguas

Registration No. 31,051 Attorney for Applicant(s)

Date: March 23, 2006

Katten Muchin Rosenman LLP 525 W. Monroe Street Chicago, Illinois 60661-3693 Telephone: (312) 902-5200

Facsimile: (312) 902-1061

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Page 1 of 3



United States Patent and Trademark Office

ES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Virginia 22313-1450

FILING OR 371 APPL NO. ART UNIT FIL FEE REC'D ATTY.DOCKET NO **DRAWINGS** TOT CLMS IND CLMS (c) DATE 09/14/2005 10/519,699 2881 211843-00032

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt Incorporating the requested corrections (if appropriate).

2880

CONFIRMATION NO. 6928

FILING RECEIPT

*OC000000017810367

Date Mailed: 01/11/2006

27160

1313 PHARMACEUTICALS INC.

1898 RUTHERFORD RD. CARLSBAD, CA 92008

PATENT ADMINISTRATOR KATTEN MUCHIN ROSENMAN 525 W. MONROE ST. CHICAGO, IL 60661-3693

Applicant(s)

Boxborough Thomas N. Horsky, Bozborough, MA; Dale Jacobson, Salem, NH;

Power of Attorney: The patent practitioners associated with Customer Number 27180.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/US03/20197 06/26/2003 which claims benefit of 60/463,965 04/18/2003 and is a Cip of 10/183,768 06/26/02

Foreign Applications

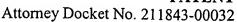
Projected Publication Date: 04/20/2006

Non-Publication Request: No

Early Publication Request: No

Title

Ion implantation device and a method of semiconductor manufacturing by the implantation of boron hydride cluster ions



THE U.S. PATENT AND TRADEMARK OFFICE

Application No.:

10/519,699

Filing Date:

December 23, 2004

Art Unit:

Not yet received.

Confirmation No.:

6928

Inventor(s):

Horsky

Title:

An Ion Implantation Device and a Method of Semiconductor Manufacturing

by the Implantation of Boron Hydride Cluster Ions

CORRECTION OF ENTITY STATUS AND PAYMENT OF FEE DEFICIENCY

Sir:

This communication serves to notify the U.S. Patent and Trademark Office of a correction to the entity status of the instant application and to pay the balance of deficient fees.

On the date of filing, December 23, 2004, it was believed in good faith that the application qualified for small entity fees. However, it is now apparent that small entity status was claimed (and small entity fees were paid) in error.

In order to correct the error, the deficiency owed is itemized in accordance with 37 CFR § 1.28(c)(2)(ii) as follows:

Serial No. 10/519,699

Page 2

Type Oi-fee Erronfously Paid As a small entity	Current fee Amount for A Non-Small Entity	SMALL ENTITY FEE ACTUALLY PAID/ DATE OF PAYMENT	DEFICIENCY OWED AMOUNT
Basic National Fee	\$300	\$150 December 23, 2004	\$150
Examination Fee	\$200	\$100 December 23, 2004	2100
Search Fee	\$500	\$250 December 23, 2004	\$250
Late oath/leclaration surcharge	\$130	\$65 Decomber 23, 2004	\$65
Total clains	\$950	\$475 December 23, 2004	\$475
Independent claims	\$800	\$400 December 23, 2004	\$400
TOTAL			\$1,440.00

The Commissioner is hereby authorized to charge \$1,440.00 for the payment of the deficiencies to Deposit Account No. 50-1214. The Commissioner is also hereby authorized to charge any additional deficiencies in the payment of the fees or credit any overpayment to Deposit Account No. 50-1214. A duplicate copy of this notification is enclosed.

John S. Paniaguas
Axiomey for Applicant(s)
Reg. No. 31,051

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Approved for use through 07/31/2006. OMB 0651-0032

U.S. Patent and Trademerk Office; U.S. DEPARTMENT OF COMMERCE

Beenwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Attorney Docket **Attorney Docket** DECLARATION FOR UTILITY OR 211843-00032

DESIGN

PATENT APPLICATION

Control of the contro

Number

First Named Inventor

Thomas N. Horsky, et al.

(37 CFR 1.63)			COMPLETE IF KNOWN					
Declaration Submitted OR With Initial Filing	Declaration Submitted after initial Filing (surcharge (37 CFR 1.18 (e)) required)		Application Number	10/519,699				
			Filing Date	December 23, 2	004			
		Art Unit	Unknown	Unknown				
		Examiner Name	Unknown					
I hereby declare that:								
Each inventor's residence, mailing address, and citizenship are as stated below next to their name.								
I believe the inventor(s) named below to be the existence and first								
An Ion Implantation Device and a Method of Semiconductor Manufacturing by the Implantation of Boron Hydride Cluster Ions								
I MARIAN OF BOTON Hydride Cluster Ions								
the specification of which (Title of the Invention)								
are specification of which								
is attached hereto								
OR				·				
was filed on (MM/DD/YYYY) 06/23/2003 00 Holland Could be determined.								
as United States Application Number or PCT International								
Application Number PCT/US03/20197 and was amended on (MM/DD/YYYY) (If applicable).								
I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment specifically referred to above.								
,								
I acknowledge the duty to disclose information which is material to patentability as defined in 37 CFR 1.56, including for continuation-in-part applications, material information which became available between the filing date of the prior application and the national or PCT international filing date of the continuational part application.								
and the national or PCT international filing data of the continuation in a valuable between the liling data of the prior application								
inventor's or plant breeder's rights configurately 2.3.C. 119(a)-(d) or (f), or 365(b) of any foreign application(s) for natent								
country other than the United States of America, listed below and have also identified below, by checking the box, any foreign before that of the application on which priority is claimed.								
perore that of the application of	on which prioring	aders rights certificate y is claimed.	e(s), or any PCT intern	ational application i	naving a filing date			
Prior Foreign Application Number(s)		Foreign Filing D	Date Priorit	V Certified	Copy Attached?			
PCT/US2003/020197	Country	(MM/DD/YYY)	Not Clain	ned YES	NO NO			
	PCT	06/23/2003			V			
"								
Additional foreign application numbers are listed on a supplemental priority data sheet PTO/SB/02B attached hereto								
at later of a supplemental priority data sheet PTO/SB/02B attached hereto								

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[Page 1 of 2]

[Page 1 of 2]

[And by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to take 21 case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED of Vou need assistance completion the form cell 1-200-DTC-2409 and select outer?

If you need assistance completing the form, call 1-800-PTO-9199 and select option 2.

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PTO/58/01 (04-05)

Approved for use through 07/31/2008. OMB 0651-0032

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

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DECLARATION — Utility or Design Patent Application Direct all The address OR correspondence to: Correspondence associated with 27160 address below **Customer Number:** Name Address City State ZIP Country Telephone Email I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under 18 U.S.C. 1001 and that such willful false statements may jeopardize the validity of the application or any patent issued thereon. NAME OF SOLE OR FIRST INVENTOR: A petition has been filed for this unsigned inventor Given Name (first and middle [if any]) Family Name or Surname Thomas N. Horsky Inventor's Signature Date Residence: City State Country Citizenship Boxborough MA USA USA Malling Address 816 Depot Road City State Zip Country Boxborough MA 01719 U8A NAME OF SECOND INVENTOR: A petition has been filed for this unsigned inventor Given Name (first and middle [if any]) Family Name or Surname Dale C. Jacobson Inventor's Signature Date Residence: City State Country Citizenship Salem USA USA Malling Address 16 Filntlock Road City State Zip Country Salem NΗ 03079 USA Additional inventors or a legal representative are being named on the supplemental sheet(s) PTO/SB/02A or 02LR attached hereto.



IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.:

10/519,699

I.A. Filing Date:

June 26, 2003

Inventor(s):

Horsky, et al.

Title:

Ion Implantation Device and a Method of Semiconductor Manufacturing

by the Implantation of Boron Hydride Cluster Ions

Group Art Unit No.: 2881

Confirmation No.:

6928

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to examining the instant application on the merits, please enter the following preliminary amendment.

Amendment to the Specification is reflected on page 2.

Remarks begin on page 3 of this paper.

AMENDMENT TO THE SPECIFICATION

On page 1 please delete the paragraph under "Cross Reference to Related Applications" and replace it with the following:

This application is the U.S. national phase under 35 U.S.C. § 371 of International Patent Application No. PCT/US03/20197, filed on June 26, 2003, which claims priority to and the benefit of U.S. Provisional Patent Application No. 60/463,965, filed on April 18, 2003, and which also is a continuation-in-part of U.S. Patent Application No. 10/183,768, filed on June 26, 2002.

Application No. 10/519,65 Attorney Docket No. 211843-00032 January 20, 2006

REMARKS

It is respectfully requested that the instant Preliminary Amendment be entered prior to examination. It is also respectfully submitted that the instant application is the national phase of International Application No. PCT/US2003/020197, filed on June 26, 2003. The priority in the amendment is the same priority set forth and accepted in the US/RO during the international phase. As such, it is Applicant's position that a Petition under 37 C.F.R. § 1.78(a)(3) is not required since the instant preliminary amendment is merely to clarify the language of the priority claim. However, should the Examiner decide that a Petition is required, the Examiner is respectfully requested to notify the undersigned attorney for applicant.

Respectfully submitted,

KATTEN MUCHIN ROSENMAN LLP

By:

John S. Paniaguas Registration No. 31,051

Attorney for Applicant(s)

Katten Muchin Rosenman LLP 525 W. Monroe Street Chicago, Illinois 60661-3693 Telephone: (312) 902-5200

Facsimile: (312) 902-1061